



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/814,260  
Filing Date .... March 21, 2001  
Inventor .... Scott E. Moore et al.  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 3723  
Examiner .... T. Eley  
Attorney's Docket No. .... MI22-1663  
Title: "Semiconductor Workpiece Processing Methods, A Method of Preparing  
Semiconductor Workpiece Process Fluid, and A Method of Delivering  
Semiconductor Workpiece Process Fluid to a Semiconductor Processor"

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 5/2/04

Attorney: James D. Shaurette

James D. Shaurette  
Reg. No. 39,833

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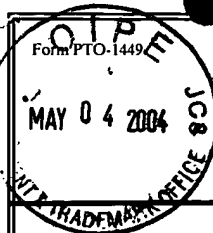
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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
M122-1663SERIAL NO.  
09/814,260LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Scott E. Moore et al.FILING DATE  
March 21, 2001GROUP  
3723

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,152,070	5/1979	Kushner et al.			
	AB	6,100,976	8/2000	Ackerson, Bruce			
	AC	5,828,458	10/1998	Taylor et al.			
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	AK	4,263,511	4/1981	Hirschberg, Joseph			
	AL	4,441,960	4/1984	Karnis et al.			
	AM	4,320,978	3/1982	Sato, Ko			
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## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AR							
	AS							
	AT							
	AU							
	AV							

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## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.